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TADES THE the Application of

Kazuhiko OKAWA, Takayuki SAIKI

Application No.: New U.S. Patent Application

Filed: May 30, 2001

Docket No.: 109657

For:

SEMICONDUCTOR DEVICE HAVING ELECTROSTATIC PROTECTION CIRCUIT

AND METHOD OF FABRICATING THE SAME

INFORMATION DISCLOSURE STATEMENT

Director of the U.S. Patent and Trademark Office Washington, D.C. 20231

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- 2. Relevance of the non-English language references is discussed in the present specification.
- 3. English-language Abstracts of the non-English language references are attached hereto.

Respectfully submitted,

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Date: May 30, 2001

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